Kevin G. Donohoe	
09/894,460	INFORMATION
June 28, 2001	DISCLOSURE
2825	STATEMENT
Igwe U. Anya	
6410	
400.100US01	
	09/894,460 June 28, 2001 2825 Igwe U. Anya 6410

Mail Stop: AMENDMENT Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

In compliance with 37 C.F.R. §§ 1.56 and 1.97, et seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

As this document is being filed along with an Request for Continued Examination, Applicant believes that no fees are due. However, the Commissioner for Patents is hereby authorized to charge any additional fees to Deposit Account No. 501373.

If the Examiner has any questions or concerns regarding this application, please contact the undersigned at (612) 312-2204.

Respectfully submitted,

Date: 24 Nov 04

Reg. No. 40,697

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First Named Inventor	Kevin G. Donohoe	
Serial No.	09/894,460	INFORMATION DISCLOSURE
Filing Date	June 28, 2001	
Group Art Unit	2825	STATEMENT
Examiner Name	Igwe U. Anya	FORM PTO-1449
Confirmation No.	6410	
Attorney Docket No.	400.100US01	
Title: ETCHING OF HIGH ASPECT RATIO		Sheet 1 of 1
STRUCTURES		

Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
	6,743,727B2	06/01/04	Mathad et al.	06/05/01

Foreign Patent References					
Examiner	Foreign Pate	ent	Name	Publication	Translation
Initials	Country	No.		Date	
•					

55. 54. 7	Other References
Examiner Initials	Author, Title, Date, Pages, etc.

Examiner		Date		
Signature		Considered		
*Evaminer: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not				